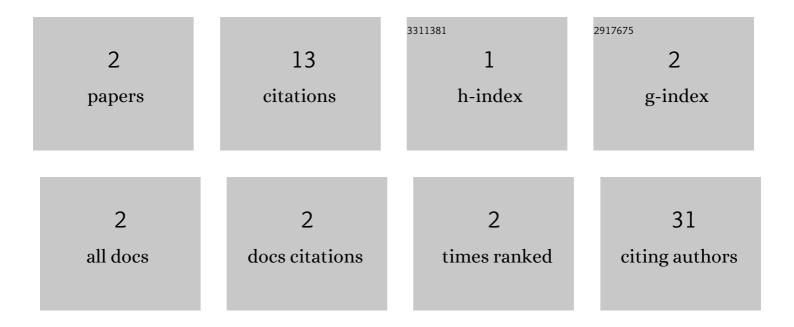
Takahiro Sato

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/8307308/publications.pdf Version: 2024-02-01



#	Article	IF	CITATIONS
1	Low damage lamella preparation of metallic materials by FIB processing with low acceleration voltage and a low incident angle Ar ion milling finish. Journal of Microscopy, 2020, 279, 234-241.	1.8	11
2	Surface morphology and dislocation characteristics near the surface of 4H-SiC wafer using multi-directional scanning transmission electron microscopy. Journal of Electron Microscopy, 2017, 66, 337-347.	0.9	2